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PATENT
Customer No. 23494
Attorney Docket No. T1-31133

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Antonio L. P. Rotondaro

Application No.: 10/001,483

Filed: November 1, 2001

For: METHOD TO IMPROVE THE
UNIFORMITY AND REDUCE THE
SURFACE ROUGHNESS OF THE
SILICON DIELECTRIC
INTERFACE

Assistant Commissioner for Patents
Washington, DC 20231

Group Art Unit: 2823

Examiner: Michelle Estrada

Sir:

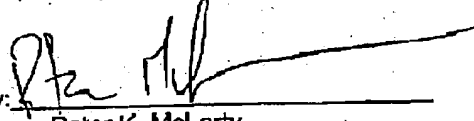
POWER OF ATTORNEY

Please grant Jonathan A. Hack, Reg. No. 47,623, power of attorney and allow
him to be an attorney of record for the above referenced application.

Respectfully submitted,

Dated: May 11, 2004

By:


Peter K. McLarty
Reg. No. 44,923

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From: Jonathan A. Hack

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Date: May 11, 2004

Re: U.S. Application No.: 10/001,483

CC:

Attorney Docket No.: TI-31133

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